

Docket: 8836-221 (IE13077-US)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Myoung-Ho Jung

Examiner: Gregory E. Webb

Serial No.: 10/748,903

Group Art Unit: 1751

Filed: December 30, 2003

For: **CLEANING SOLUTION USED IN PROCESS OF FABRICATING
SEMICONDUCTOR DEVICE**

Mail Stop: RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Do Not enter.

No RCE included

AMENDMENT

Sir:

In response to the Office Action dated December 12, 2006, please amend the
above-referenced patent application as set forth herein. Also, accompanying this
amendment is a Request for Continued Examination (RCE). ?
